

Laser beam characterization and thermal wavefront distortions in optical components

K. Mann

J.O. Dette, W. Hüttner, F. Kühl, U. Leinhos, M. Lübecke,
T. Mey, M. Müller, M. Stubenvoll, J. Sudradjat, B. Schäfer

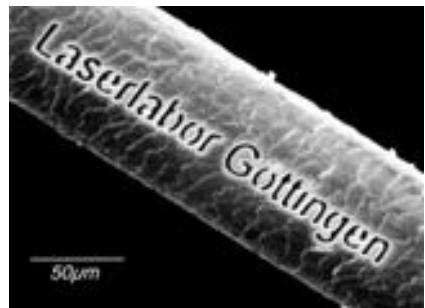
Laser-Laboratorium Göttingen e.V.
Hans-Adolf-Krebs Weg 1
D-37077 Göttingen



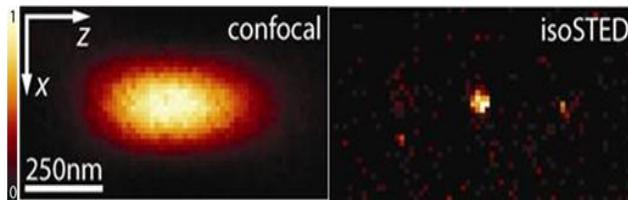
Laser-Laboratorium Göttingen



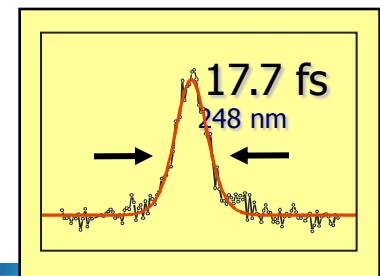
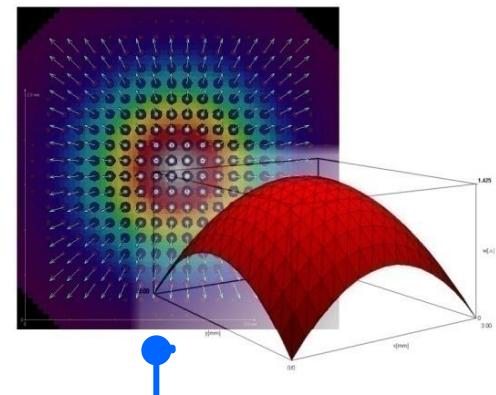
Micro Material processing



Nanoscopy



Optics / Short wavelengths



Short pulse laser technology



Spectroscopy / Sensorics



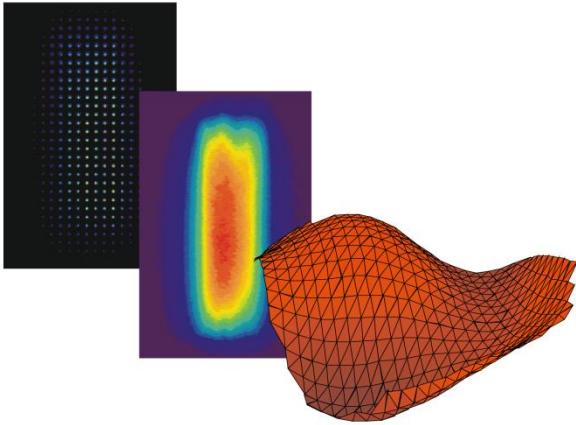
Dept. “Optics / Short Wavelengths”



► Beam and Optics Characterization

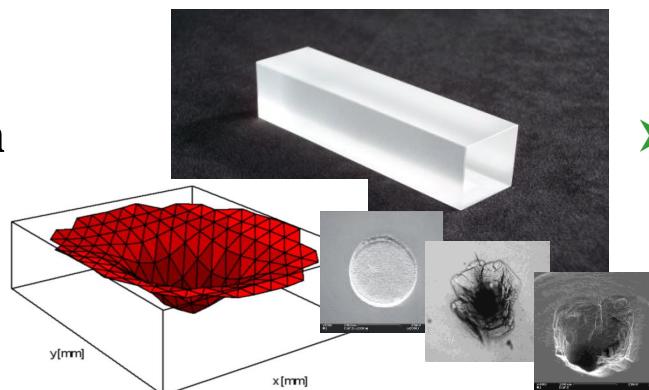
➤ Optics test (351...193 nm)

- (*Long term*) degradation (10^9 pulses)
- Non-linear processes
- LIDT
- **Absorption / Scatter losses**
- Wavefront deformation



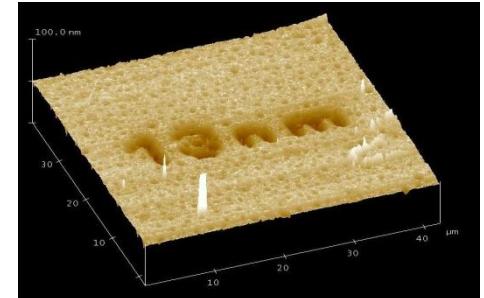
➤ Beam propagation

- Wavefront
- coherence
- M^2



➤ EUV/soft x-ray technology

- Source & Optics
- Metrology
- Material interaction



Spectrum of electromagnetic radiation

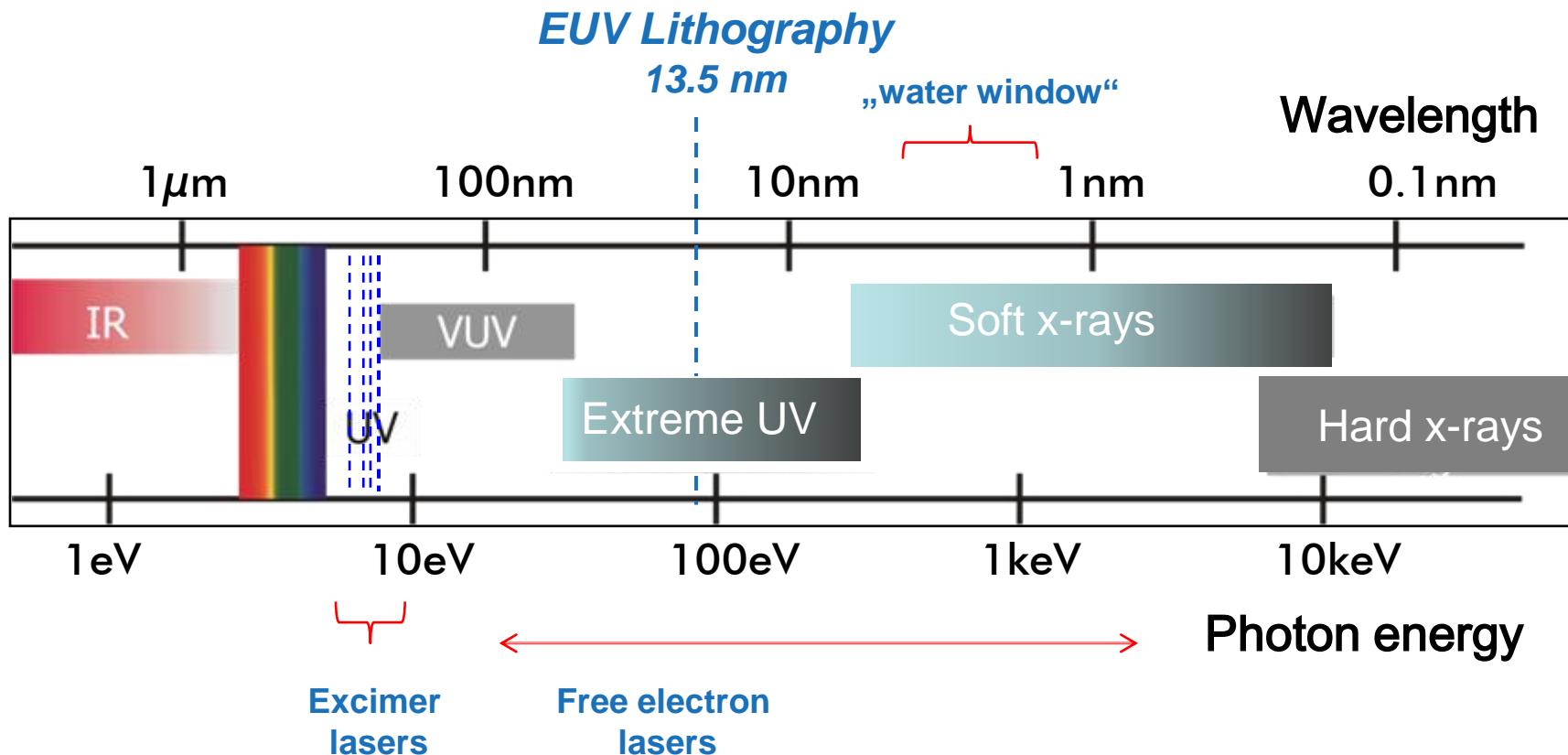
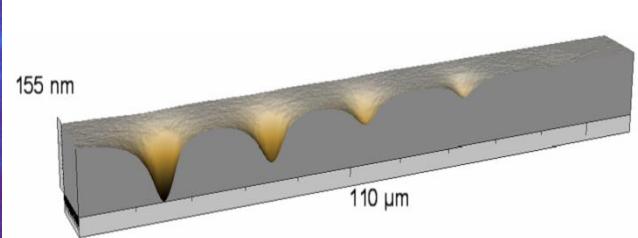
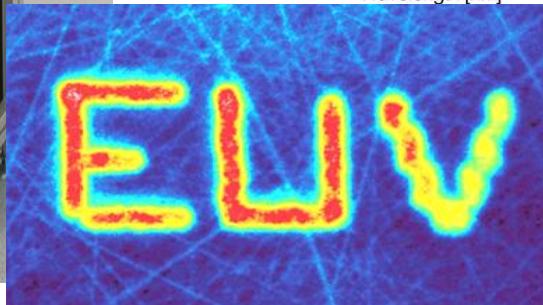
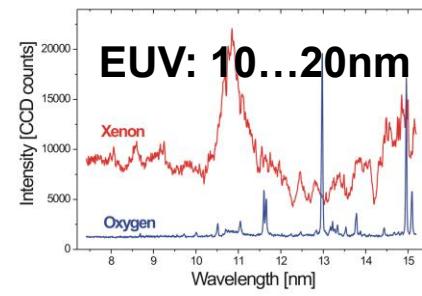
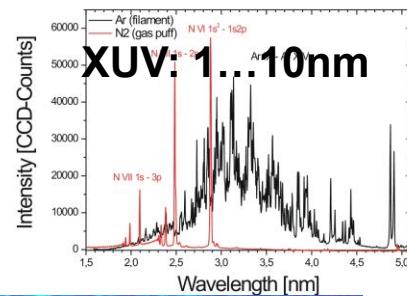
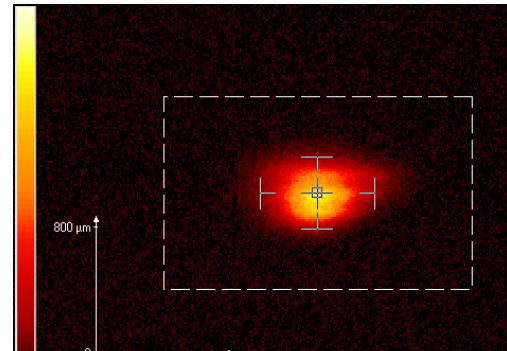
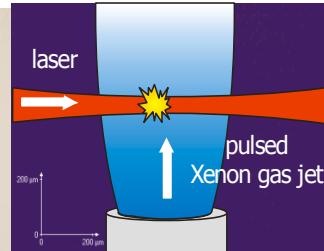


Table-top EUV source

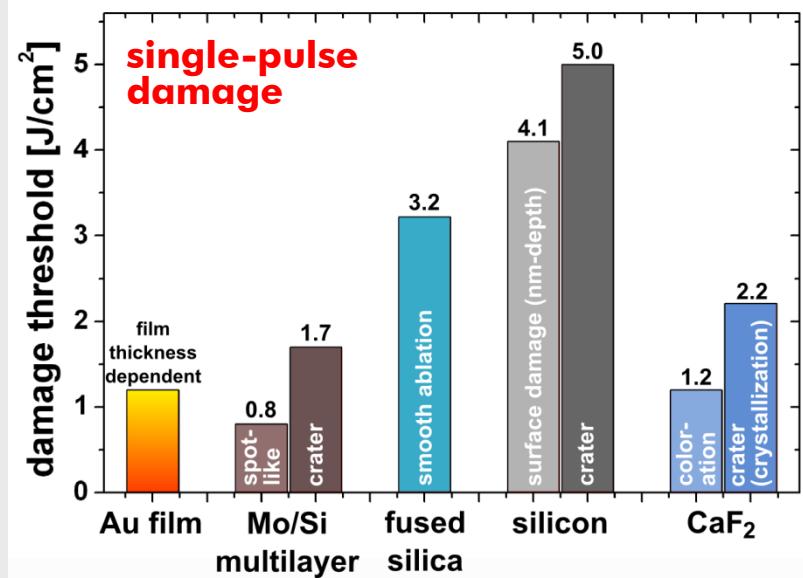
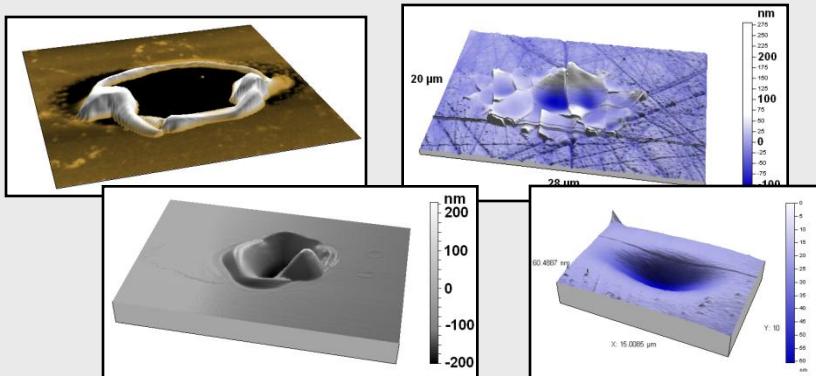


Ablation / damage thresholds @13.5nm

- ▶ Laser driven EUV/XUV plasma source setup
 - ▶ 1.2 J/cm² (@ 13.5 nm, 2 % bandwidth)
 - ▶ 7.4 J/cm² (filtered by 2 Mo/Si mirrors)



- ▶ Damage thresholds of mirrors / substrates



Outline:



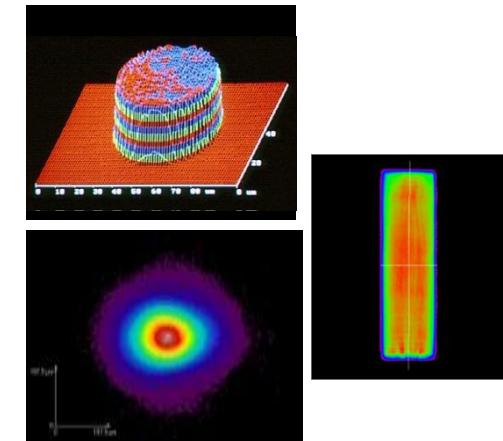
- ▶ Introduction
- ▶ Determination of beam parameters (ISO standards)
- ▶ Wavefront measurement / analysis of beam propagation
- ▶ Wavefront distortion in high power laser optics
- ▶ Thermal lensing / Focus shift

Relevant laser parameters:



Parameters	Standard
Average power / pulse energy	ISO 11554
Wavelength / spectral band width	ISO 13695
Pulse length	ISO 11554
Polarization	ISO 12005
Beam diameter	ISO 11146
Divergence	ISO 11146
Beam profile	ISO 13694
Pointing / pos. stability	ISO 11670
M^2 / focusability	ISO 11146
Wavefront / phase distribution	ISO 15367
coherence	-

Propagation

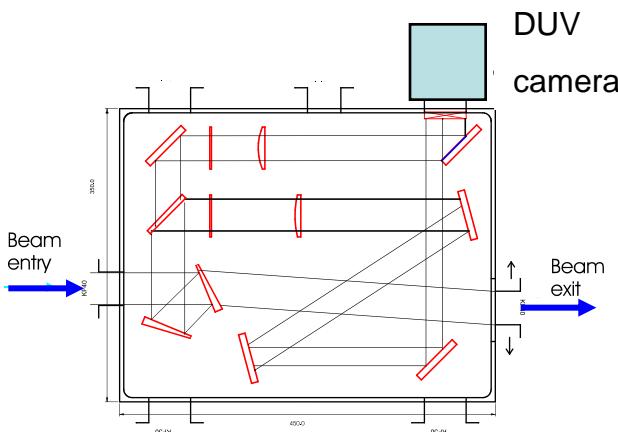


**Spatially
resolved
measurement**

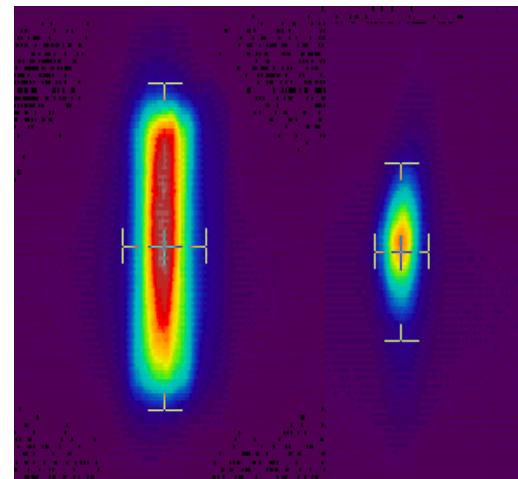
Excimer laser beam characterization



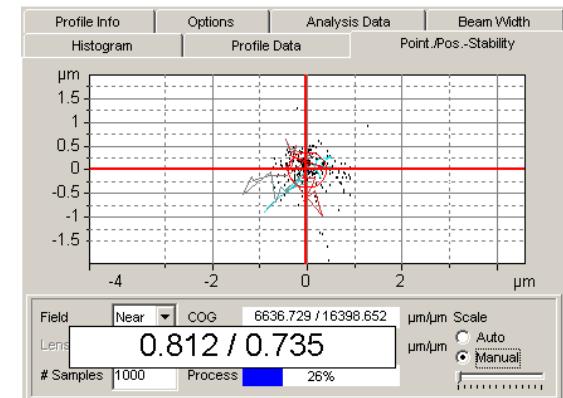
- ▶ Simultaneous near- and far-field analysis @193nm / 6kHz



Near-field far-field profile:



→ Beam width divergence

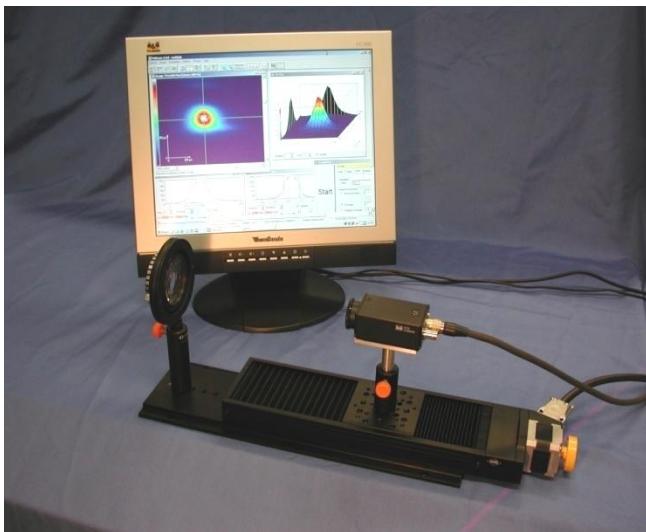


pointing stability

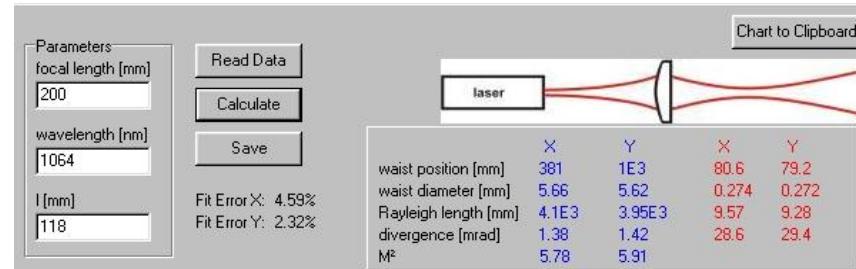
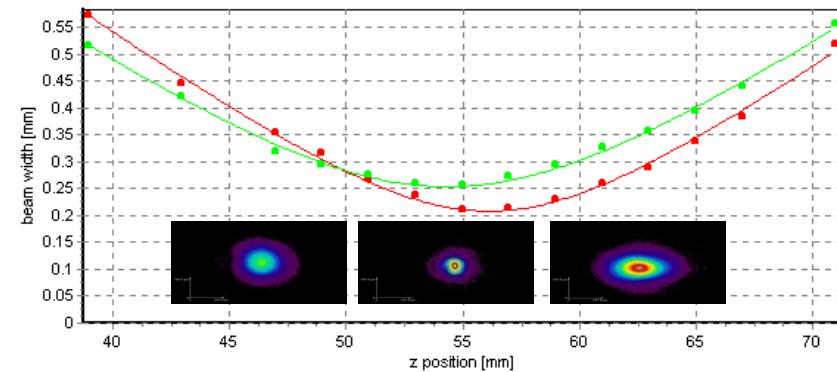
Caustic measurement (ISO 11146)



Example: Nd:YAG / 1064nm



- lens → beam waist
- $d_{\sigma,x,y}$ (2nd moment) = f (z)
- hyperbolic fit



Beam parameters

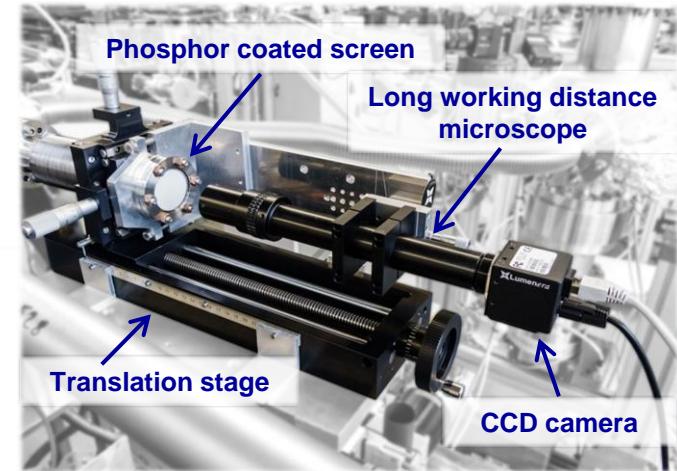
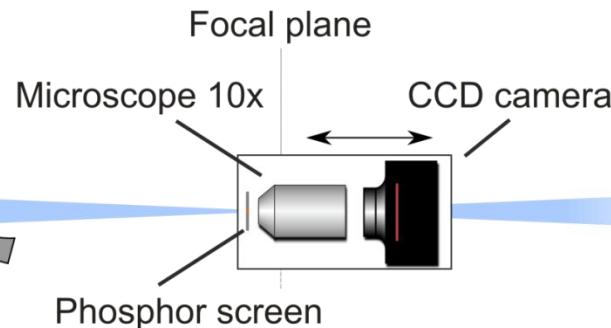
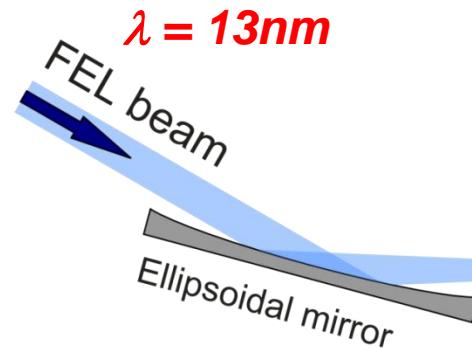
- propagation factor M^2
- divergence
- Rayleigh length
- waist diameter / position

→ all lasers

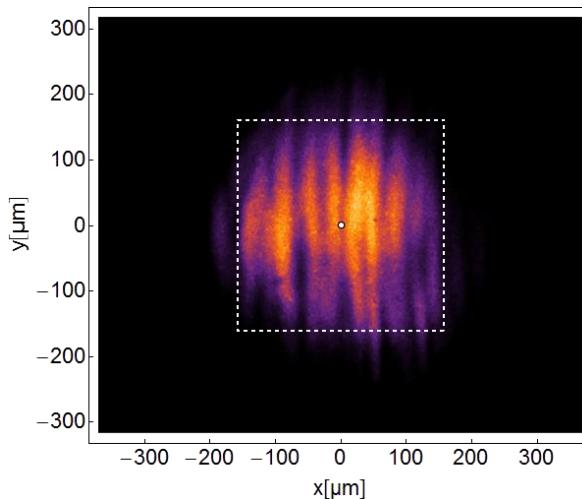
Caustic of Free Electron Laser FLASH / DESY



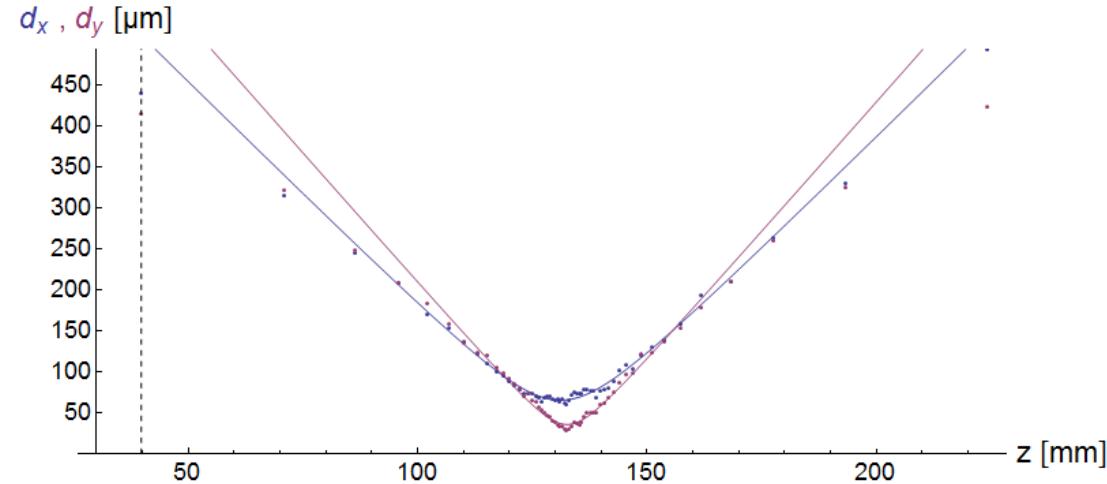
Laser-
Laboratorium
Göttingen e.V.



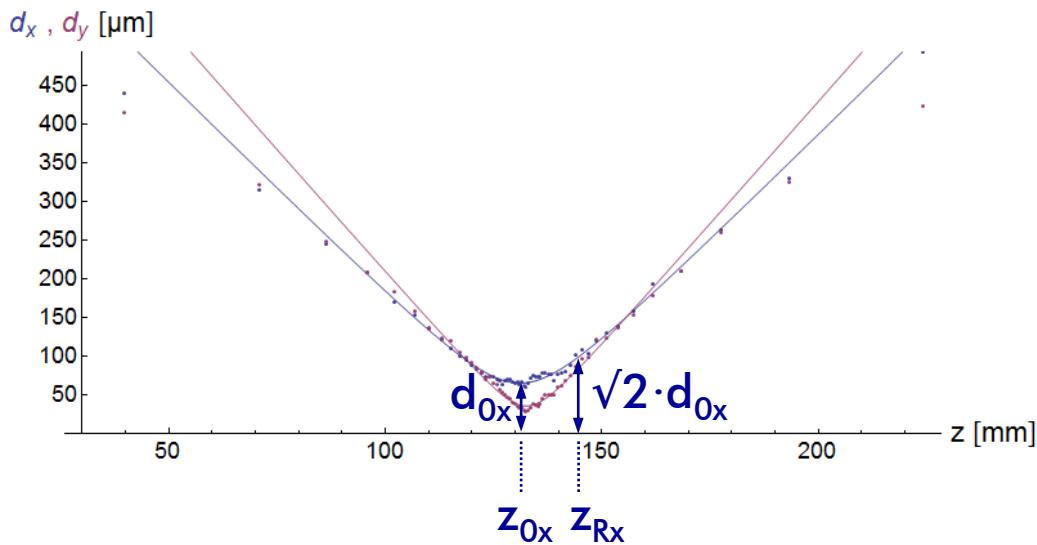
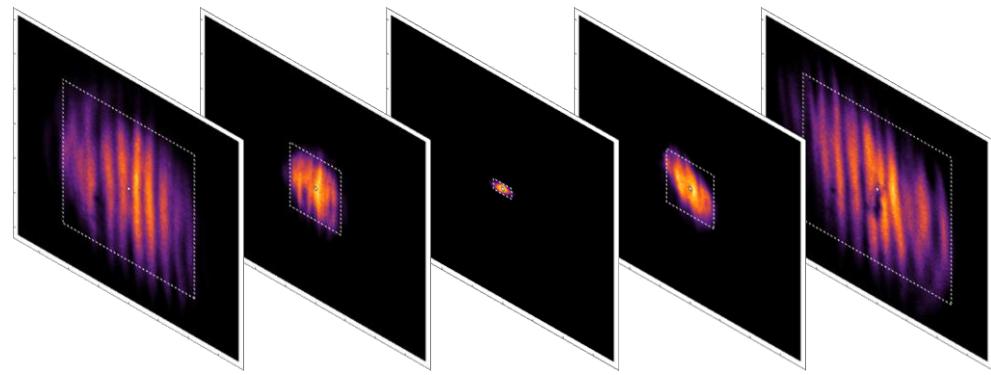
Intensity distribution



Beam diameter

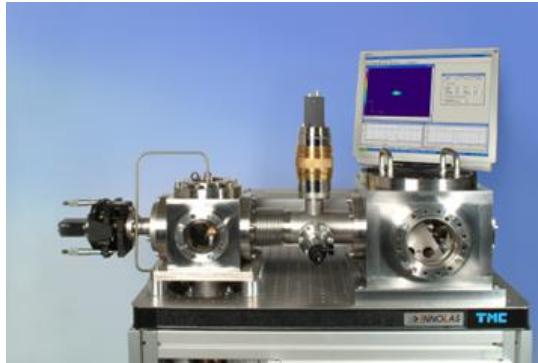


Caustic of Free Electron Laser FLASH / DESY



Beam parameter	Value
Waist position z_{0x} / z_{0y} [mm]	131.1 / 132.6
Waist diameter d_{0x} / d_{0y} [μm]	65.5 / 35.9
Rayleigh length z_{Rx} / z_{Ry} [mm]	11.8 / 5.7
Beam propagation factor M^2_x / M^2_y	21 / 13
coherence	???

Focusing of laser-induced soft x-ray plasma

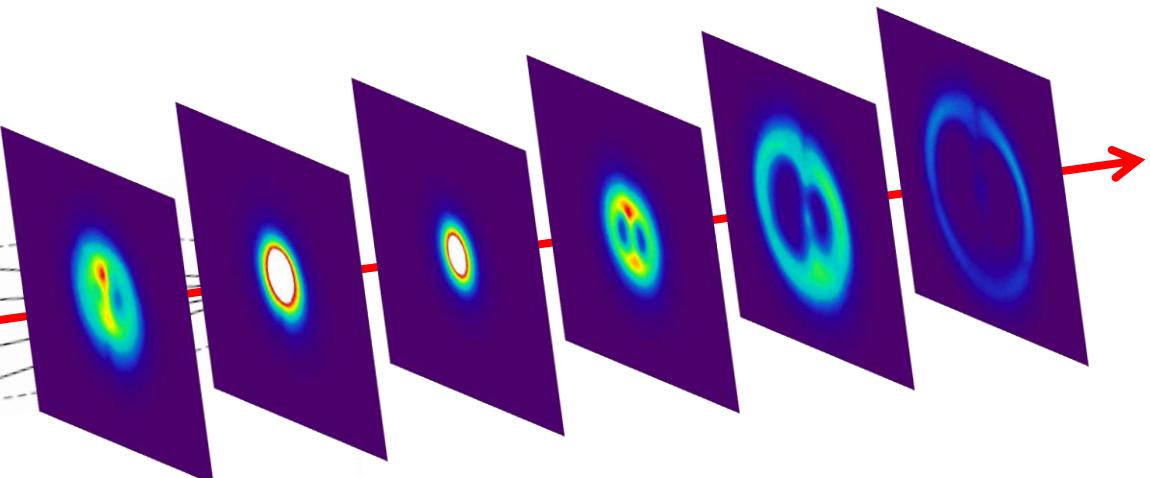
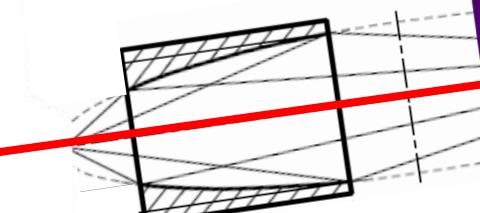
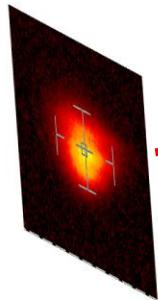


- $\lambda = 2.88\text{nm}$ (monochromatic)
- → waist dia. $\sim 500\mu\text{m}$

Grazing incidence
ellipsoidal
mirror

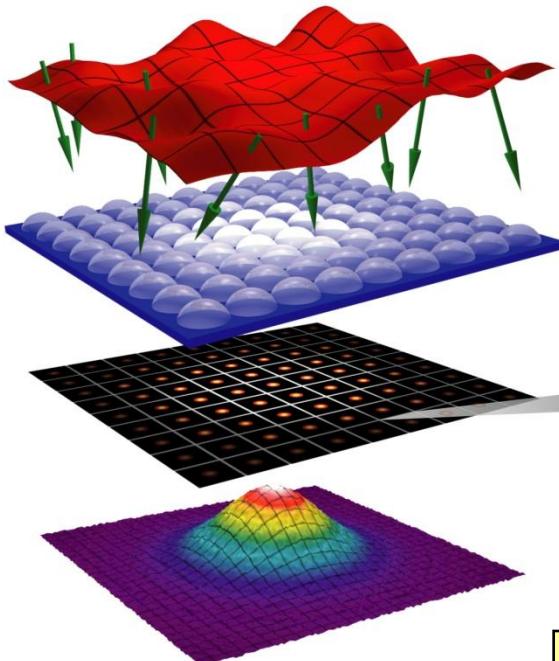
plasma

Soft x-ray camera



...time-consuming...

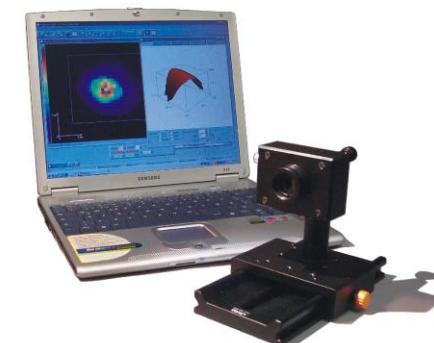
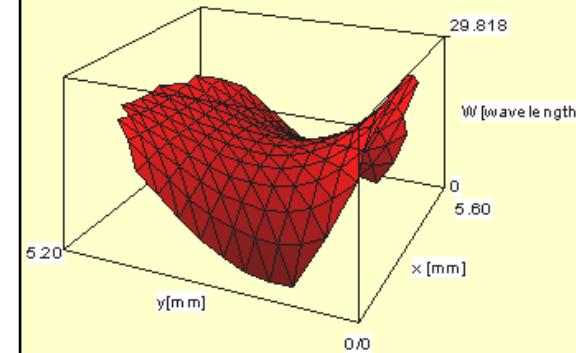
Hartmann-Shack wavefront sensor:



intensity
distribution

directional
distribution

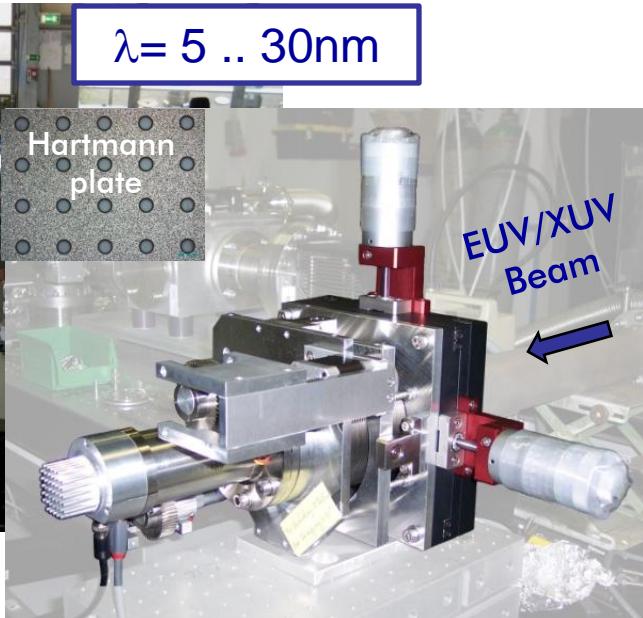
⇒ Wavefront $w(x,y)$
= surface \perp Poynting-Vektor $S(x,y)$
(ISO 15367-2)



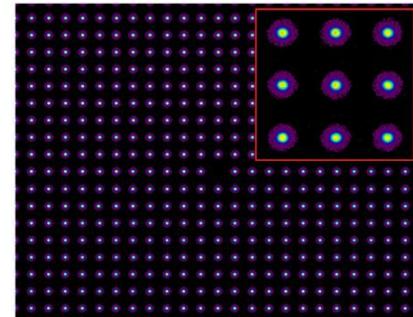
EUV wavefront sensor: Optics adjustment at FLASH FEL



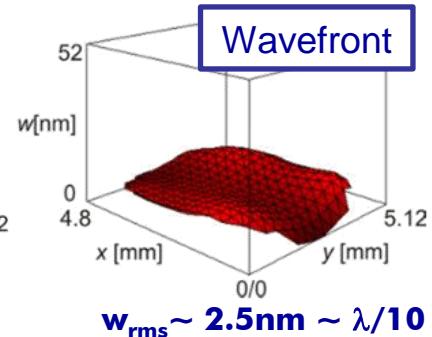
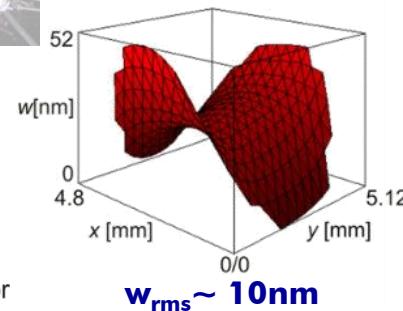
Laser-
Laboratorium
Göttingen e.V.



Spot distribution:



Wavefront before and after
mirror adjustment:



Experimental setup (BL2):



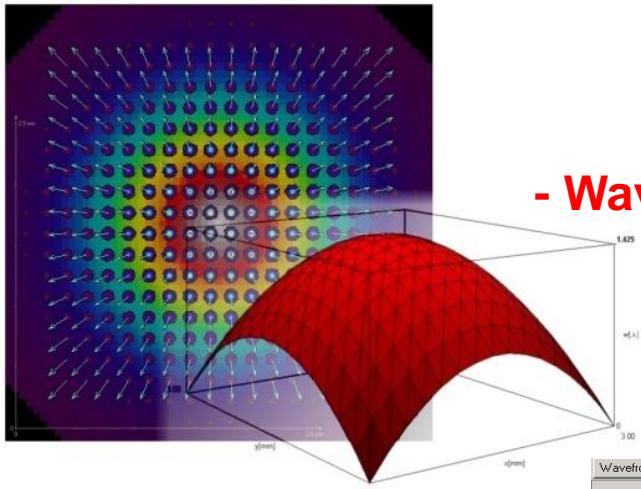
Beam characterization:

Hartmann-Shack wavefront sensor



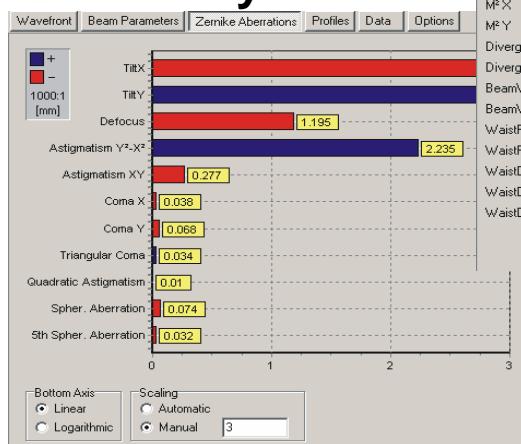
Spot distribution →

- Beam profile



- Wavefront

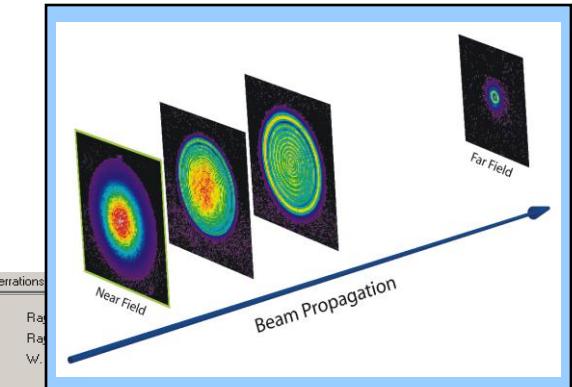
Zernike
Analysis:



Propagation
analysis

Beam
parameters:

Wavefront		Beam Parameters		Zernike Aberrations	
Irregularity	0.0040167	[mm]	RMS Deformation	0.0004581	[mm]
Defocus	250.3714252	[mm]	General Astigm.	0.0171251	[mm]
M²	1.4916478				
M² X	1.6479686				
M² Y	1.5580992				
Divergence X	0.9524476	[mrad]	Divergence 45°	3.5551474	[mrad]
Divergence Y	1.9474767	[mrad]	Divergence 135°	4.3566263	[mrad]
BeamWidth X	1.6392648	[mm]	BeamWidth 45°	1.7467004	[mm]
BeamWidth Y	1.348.2168254	[mm]	BeamWidth 135°	1.8517269	[mm]
WaistPosition X	-348.2168254	[mm]	WaistPosition 45°	-352.7441847	[mm]
WaistPosition Y	-597.6054112	[mm]	WaistPosition 135°	-354.7499939	[mm]
WaistDifference	0.2671958	[RL]	WaistDifference	0.0069633	[RL]
WaistDiameter X	0.2162982	[mm]	WaistDiameter 45°	1.2158544	[mm]
WaistDiameter Y	0.15580992	[mm]	WaistDiameter 135°	1.0199419	[mm]



$$M_x^2 = \frac{4\pi}{\lambda} \sqrt{\langle x^2 \rangle \langle \beta^x \rangle - \langle x \beta^x \rangle^2}$$

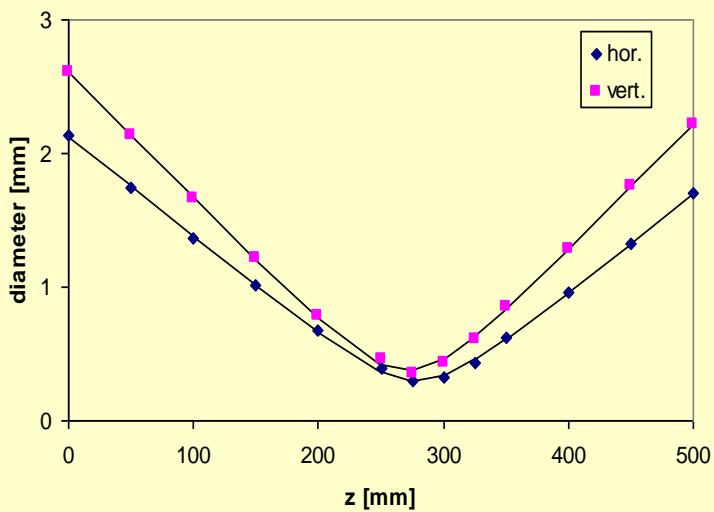
B.Schäfer, K. Mann, Rev. Sci. Instr. 77, 053103 (2006)

Collimated Diode Laser Beam

650 nm, cw, 2 mW

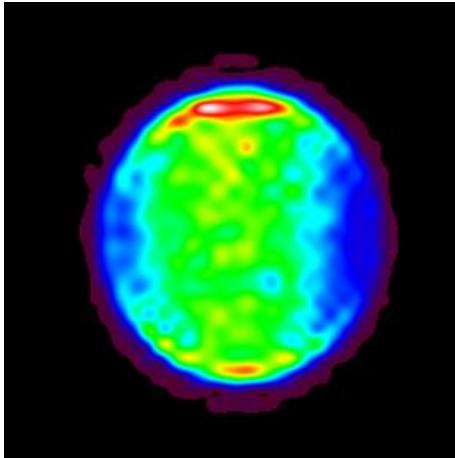


Caustic measurement



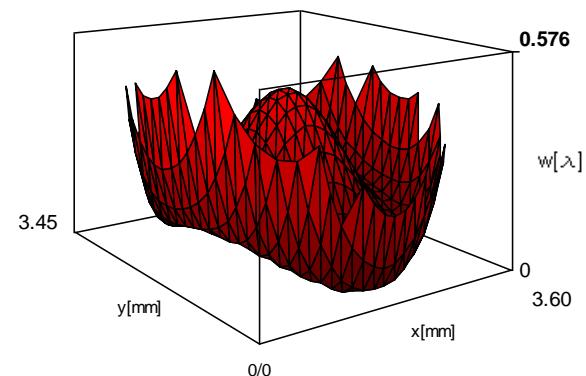
$M^2 = 2.68 / 4.26$
 $\theta_\sigma = 7.56 / 9.55 \text{ mrad}$

Hartmann-Shack (single measurement)



Profile:

Wavefront aberrations:



$M^2 = 2.52 / 4.23$
 $\theta_\sigma = 7.16 / 10 \text{ mrad}$

Prediction of beam propagation:

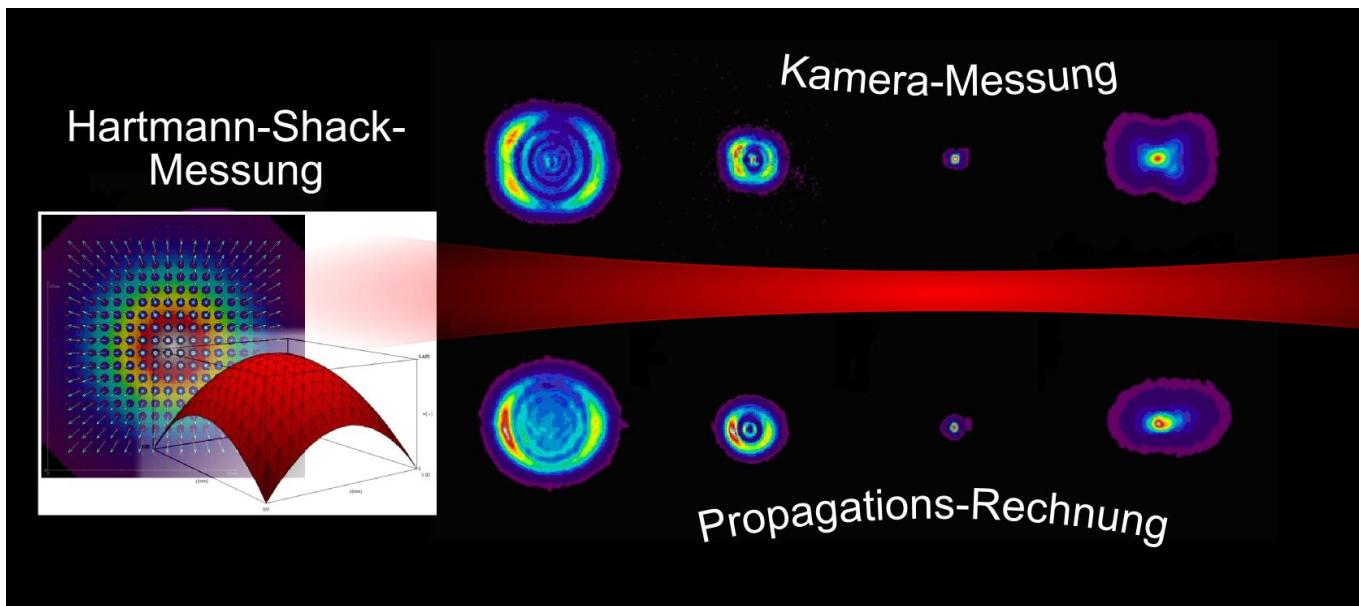
Single
Hartmann-Shack
Measurement

Wavefront $w(x,y)$
Irradiance $I(x,y)$

$$I(x, y, z) = \left| \frac{ik}{2\pi z} \iint_{-\infty}^{\infty} \sqrt{I} e^{ikw} \cdot e^{\frac{ik[(x-x')^2 + (y-y')^2]}{2z}} dx' dy' \right|^2$$

collimated diode laser:

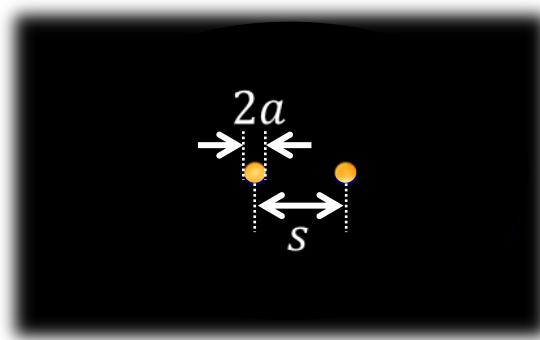
Fresnel-Kirchhoff integral



$z=0$

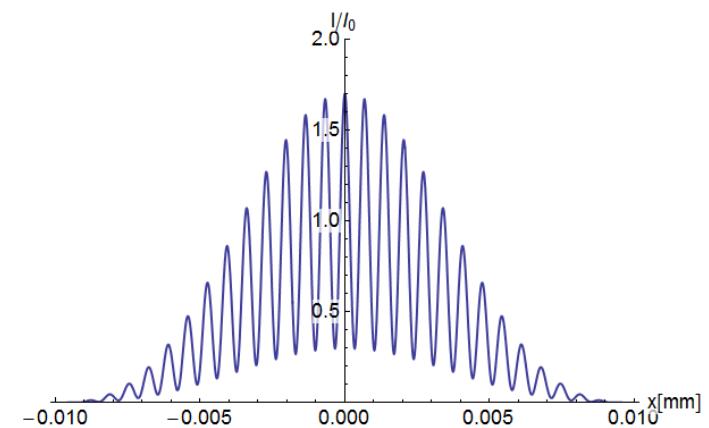
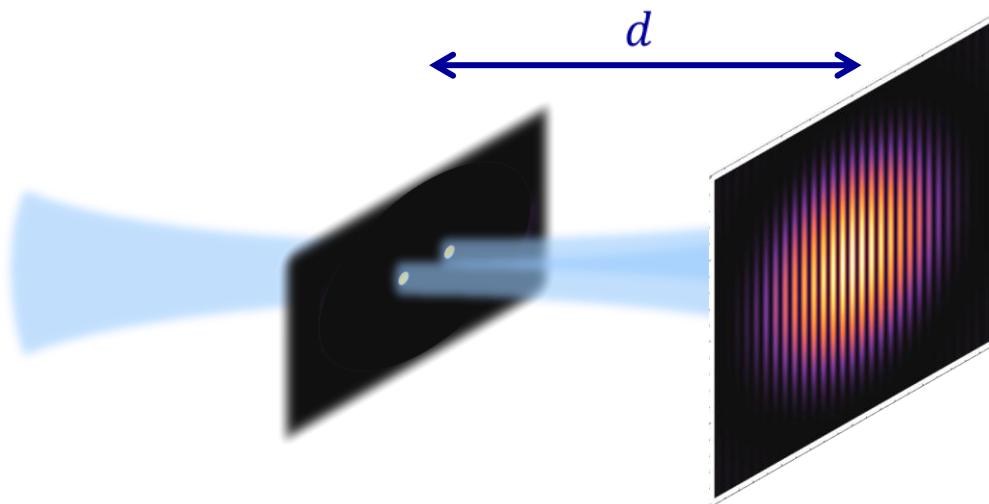
....only fully coherent beams !

Spatial coherence:

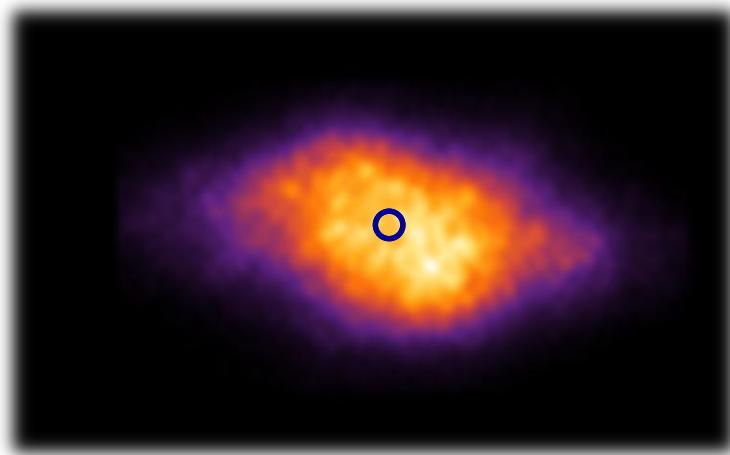


Young's experiment:
interference of elementary waves

Contrast of fringes
→ local degree of coherence $\gamma(\vec{x}, \vec{s})$:

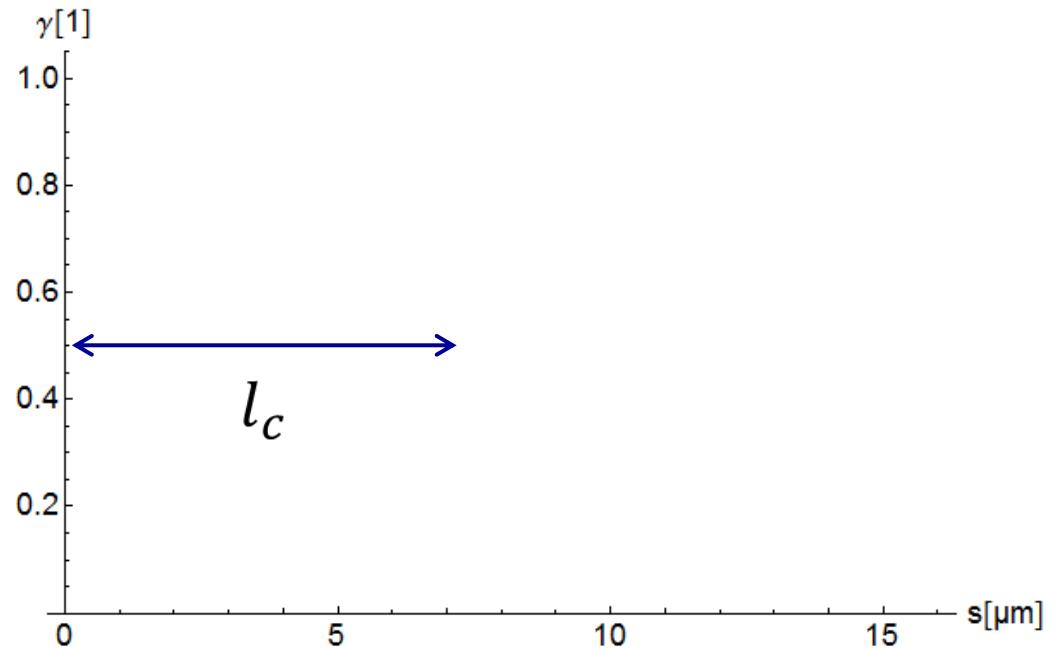


Mutual coherence function

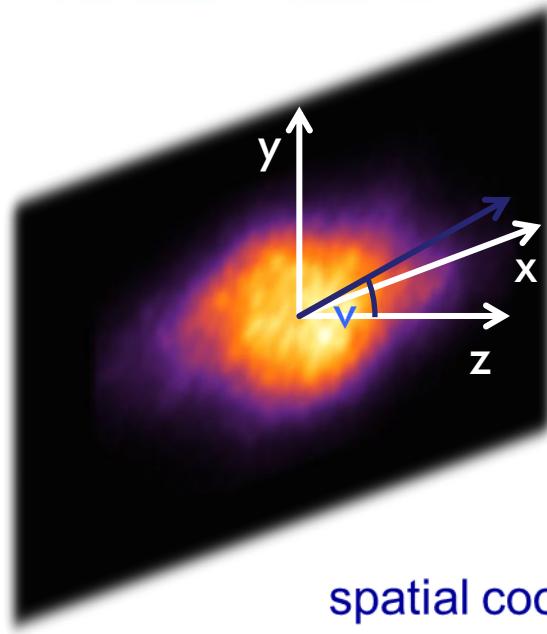


coherence length l_c

$$\gamma(0, s_x) = \frac{\Gamma(0, s_x)}{\sqrt{I(-s_x/2) \cdot I(s_x/2)}}$$



Wigner distribution



h = Fourier transform of Mutual Coherence Function:
Wigner distribution

mutual coherence function

$$h(\vec{x}, \vec{u}) = \left(\frac{1}{2\pi}\right)^2 \cdot \iint \Gamma(\vec{x}, \vec{s}) \cdot e^{-i\vec{u} \cdot \vec{s}} d^2 s$$

spatial coordinate $\vec{x} = \begin{pmatrix} x \\ y \end{pmatrix}$

angular coordinate $\vec{u} = \begin{pmatrix} u \\ v \end{pmatrix}$

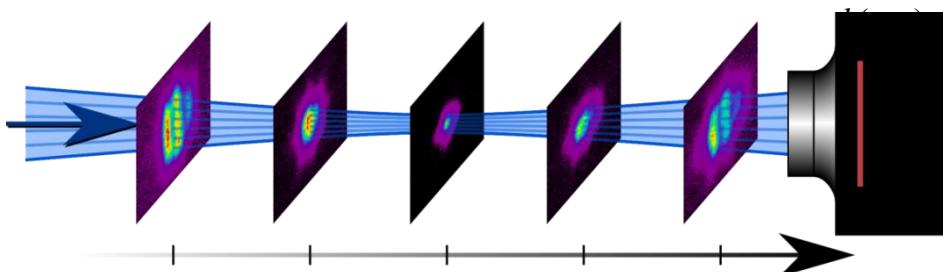
Interpretation: radiance at position \vec{x} in direction of \vec{u}

$$[h] = \text{W/m}^2 \cdot \text{sr}$$

Partially coherent beams: Measurement of Wigner Distribution



Mapping of 4D phase space:



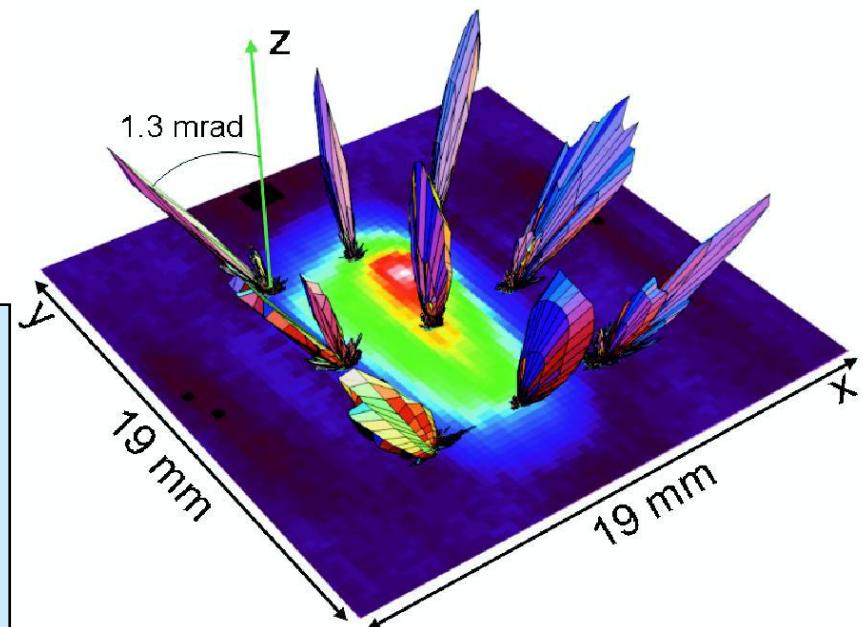
↔ Tomographic analysis of a laser beam

⇒ comprehensive beam characterization

- beam parameters
- coherence function
- mode content
- wavefront
- angular characteristics

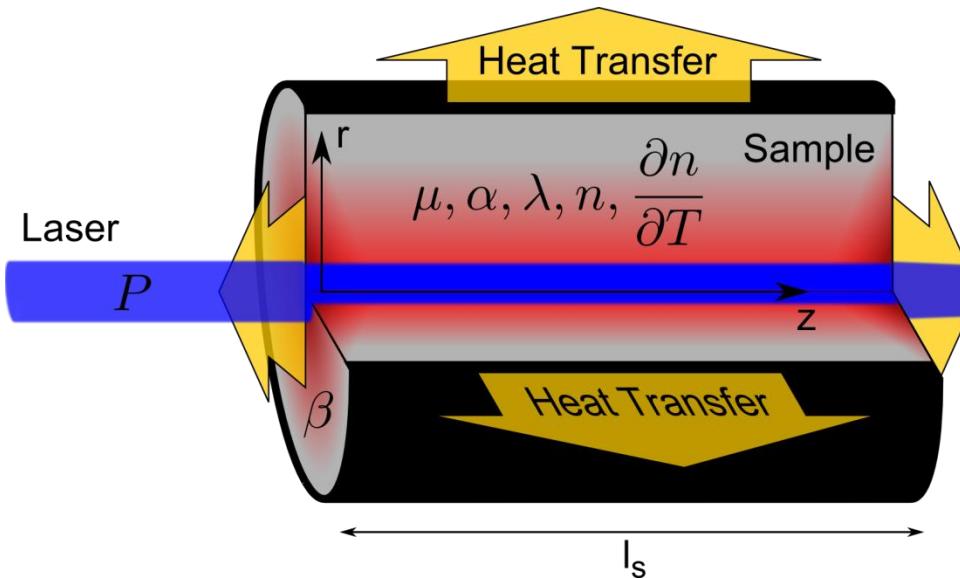
Example:

*Spatially resolved angular distribution
of excimer laser @193nm*



Optics characterization:

Photo-thermal lens effect \leftrightarrow Absorption



β = Surface Absorption Coefficient

μ = Bulk Absorption Coefficient

α = Thermal Expansion Coefficient

λ = Thermal Conductivity

n = Refractive Index

P = Laser Power

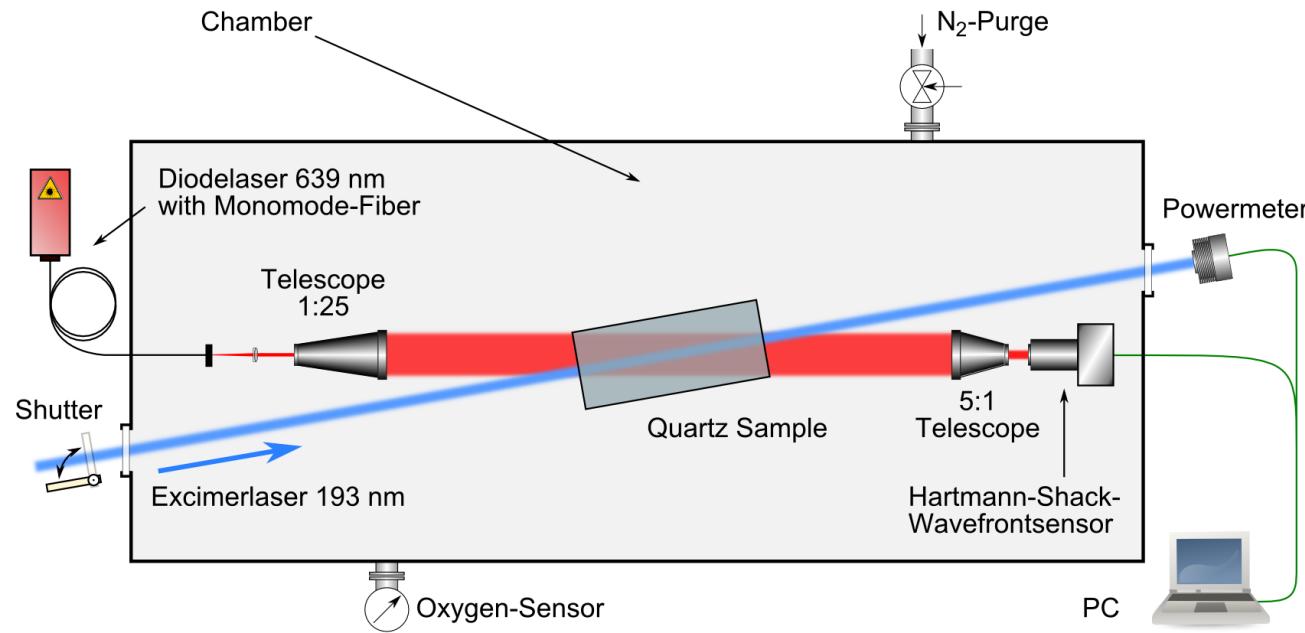
l_s = Sample Length

$$\frac{\partial n(T)}{\partial T}$$



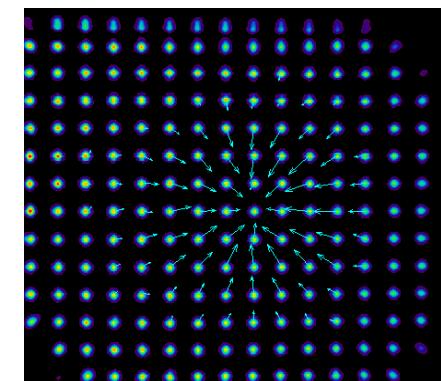
$$\delta w(r) = \left(\frac{\partial n}{\partial T}(T) + \alpha n(T) \right) \cdot l_s \cdot \delta T(r) \propto P \cdot (A_{bulk} + A_{surf})$$

Monitoring of 'Thermal lenses':

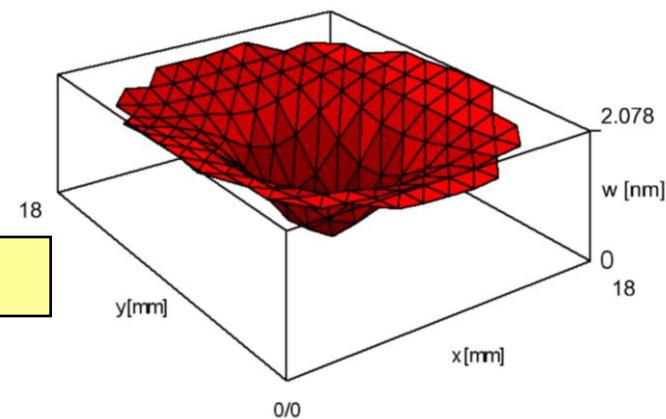


- quartz plate $\varnothing 25 \times 45\text{mm}$
- irradiated @193nm, $\sim 100\text{mW/cm}^2$

Spot diagram:



Wavefront:



⇒ Formation of thermal lens

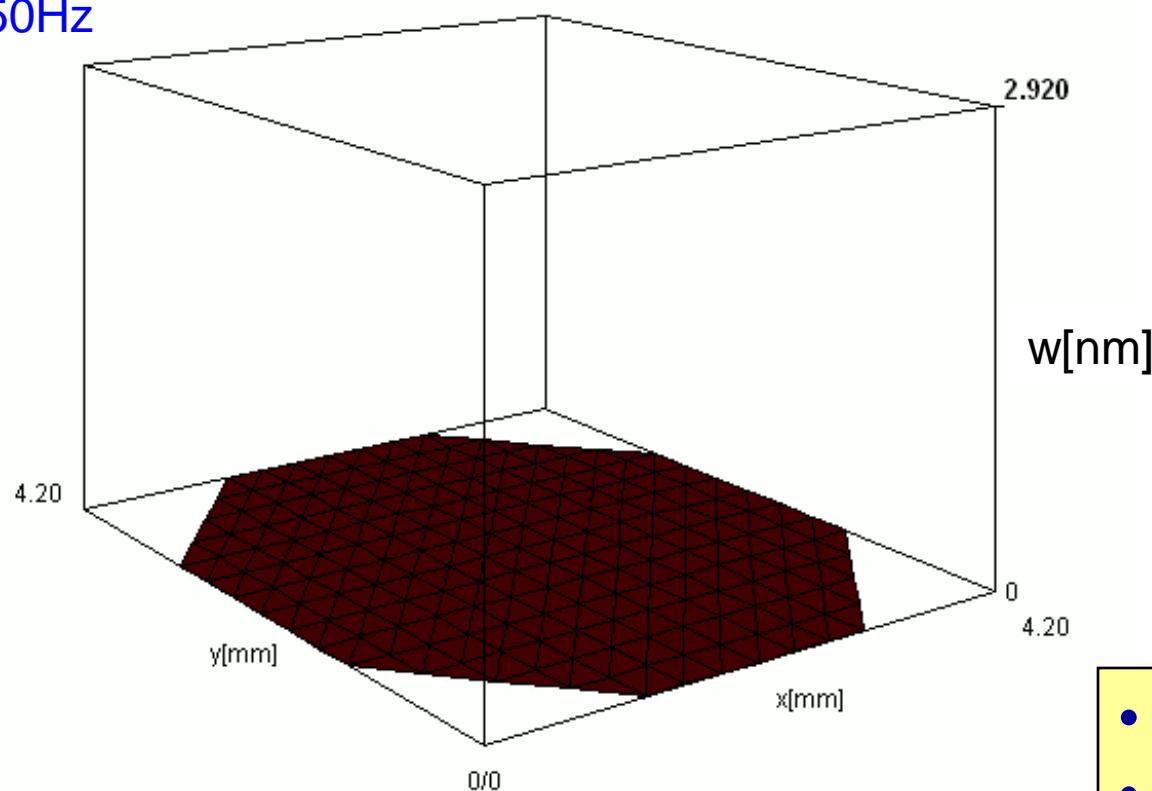
↔ Wavefront sensor of extreme sensitivity
($\sim \lambda / 10000$)

$\Delta w_{p-v} \sim 1\text{nm} \Rightarrow \text{Defocus} \sim 10\text{km} !$

Thermal lens in fused silica

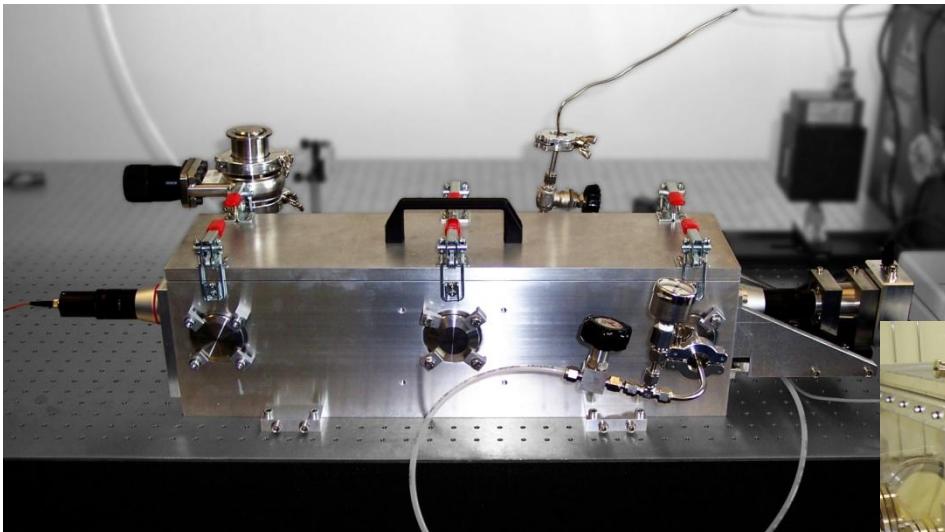


Quartz sample
@ 193nm / 150Hz
 $H \sim \text{mJ/cm}^2$



- $\tau \sim \text{sec}$
- $\Delta w \sim \text{nm}$

Photothermal setup for quantitative absorption measurement



- fused silica
- HR / AR coatings

- 193nm: $p(O_2) < 50\text{ppm}$

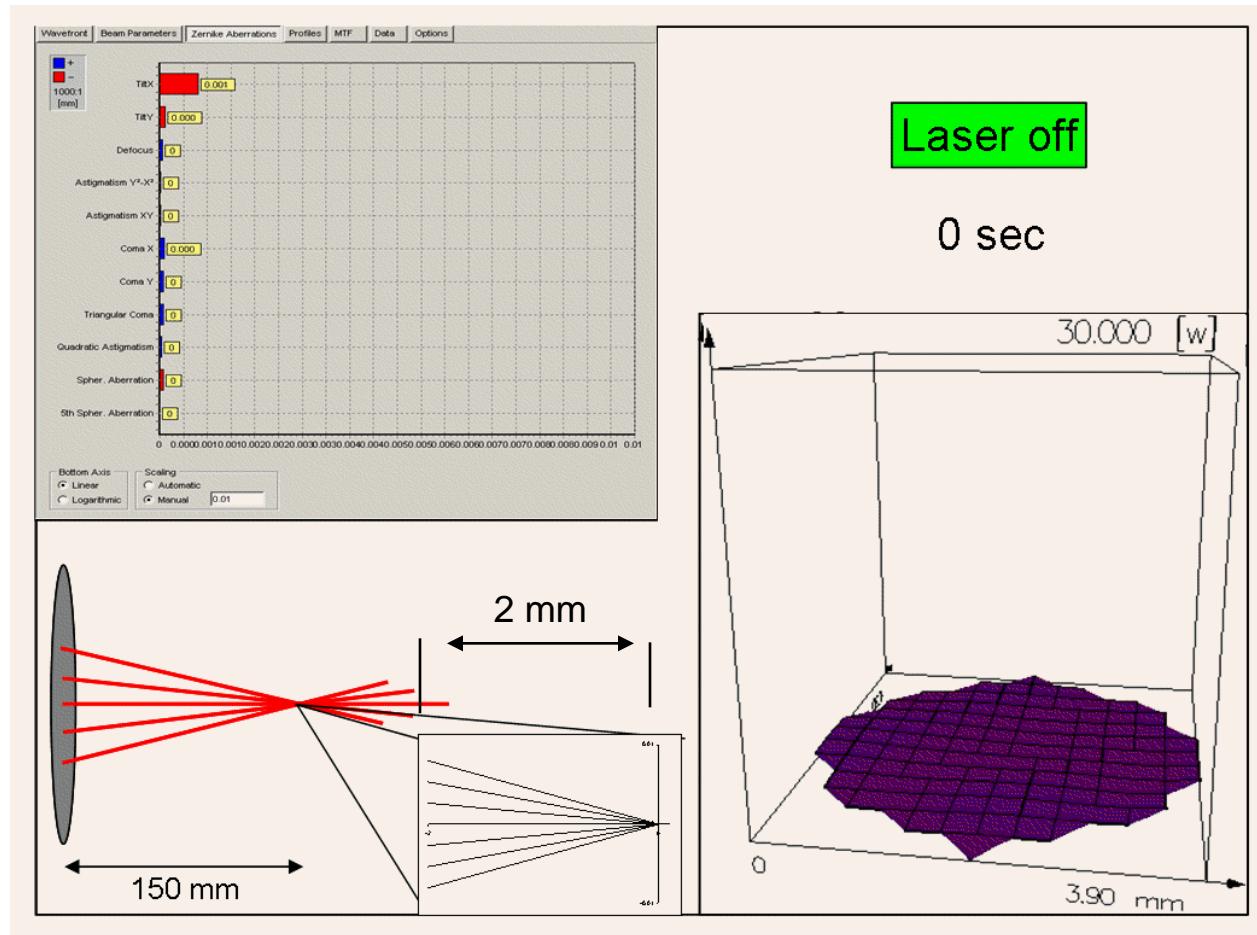


Absorption of NIR optics:

Thermal Lens in AR coated BK7 glass

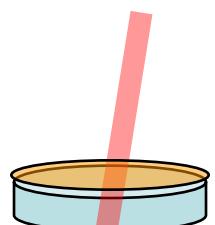


Fiber laser @1070nm / 100W



Fiber laser

$\varnothing 1.6\text{mm}$
 $P=100\text{W}$
 1070 nm



AR coating

Substrate BK7
 $\varnothing 31,5\text{mm}, l=2\text{mm}$
 $\mu\ell+2\beta \approx 65\text{ ppm}$

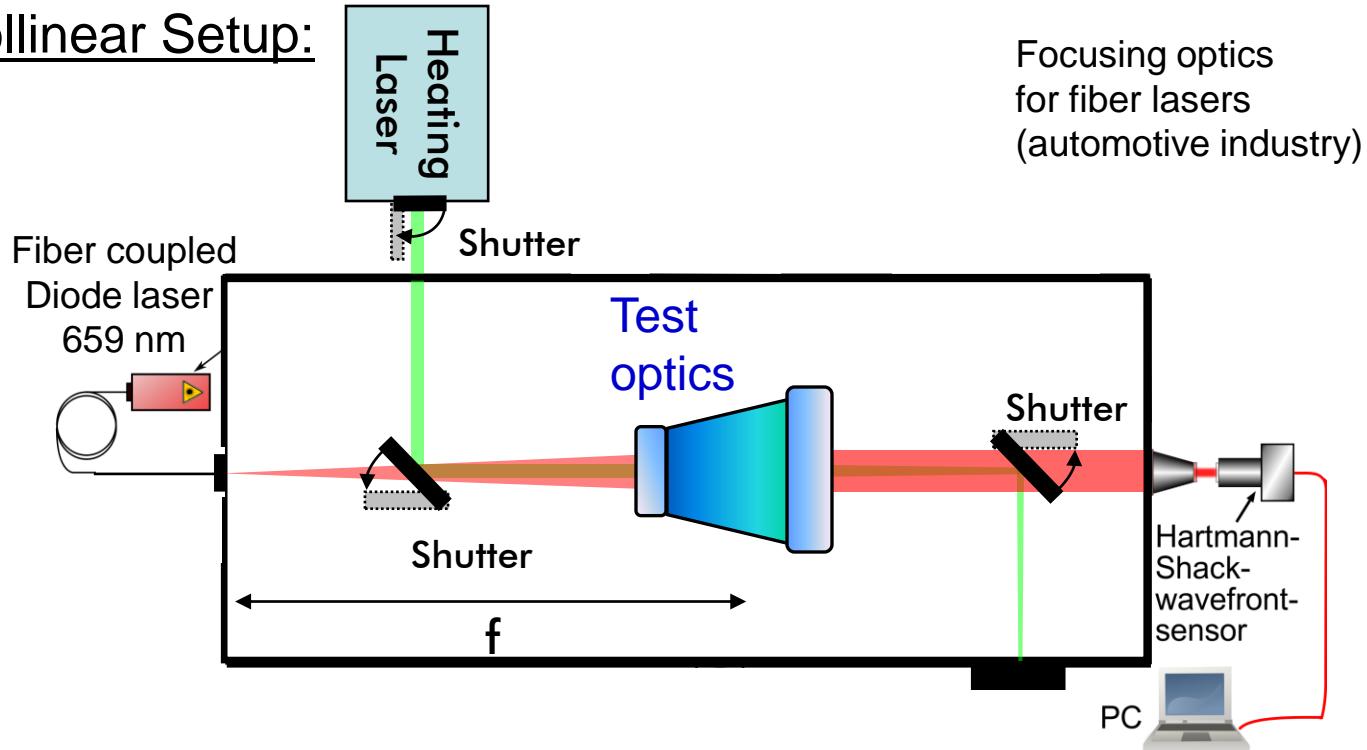
Focus shift:

$$\Delta f = \frac{d^2}{d + 0.5C_{20}^{-1}} \approx 1\text{mm}$$

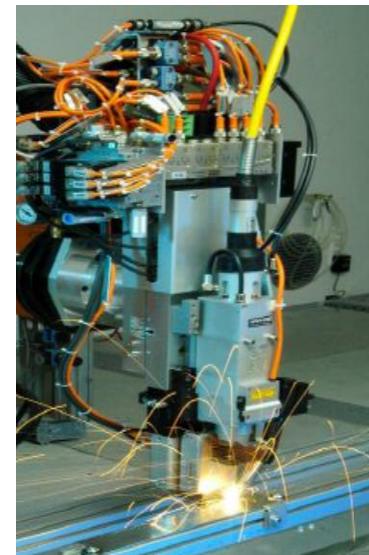
Thermal wavefront distortion in beam delivery optics



Collinear Setup:



Focusing optics
for fiber lasers
(automotive industry)

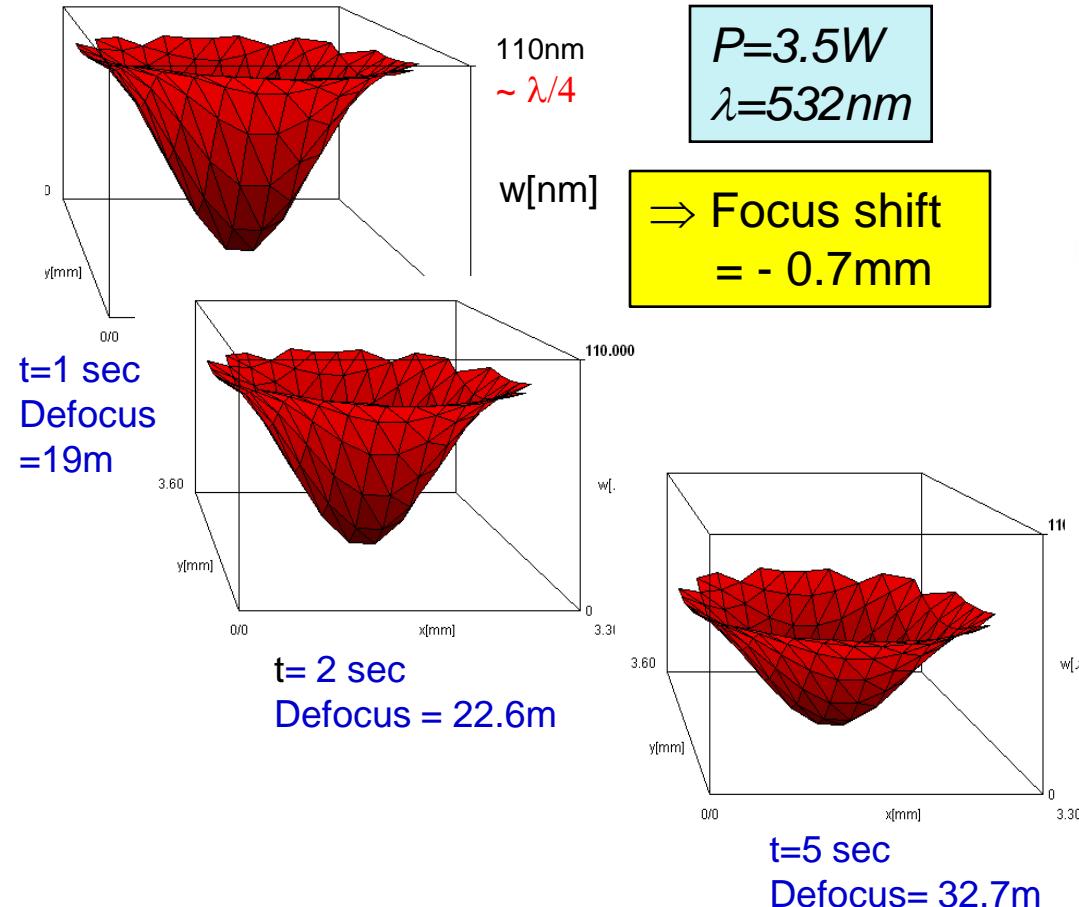


- Measurement during cooling intervals
- Investigation of complex optical systems

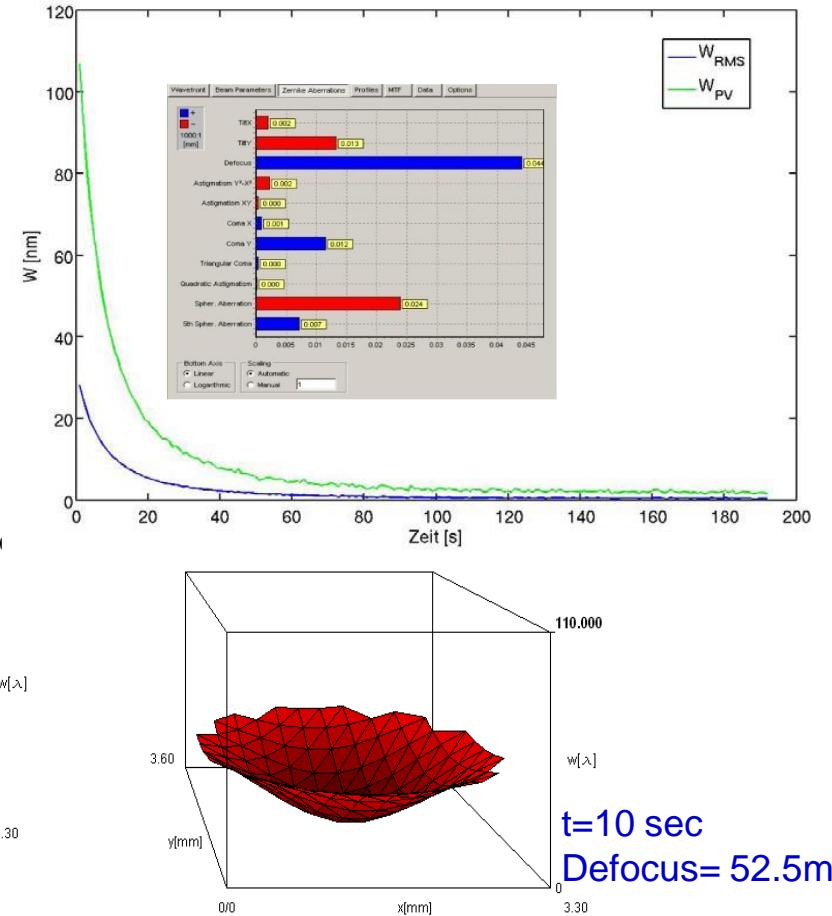
patented

Focus shift in F-Theta objective @532nm:

Wavefronts during cooling period:



Wavefront deformation vs. time:

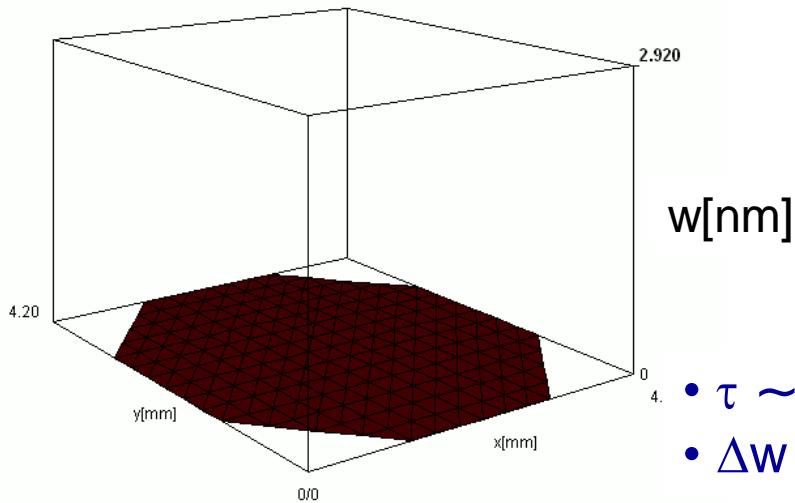


Photothermal absorption measurement

Comparison Quartz - CaF₂



Quartz:

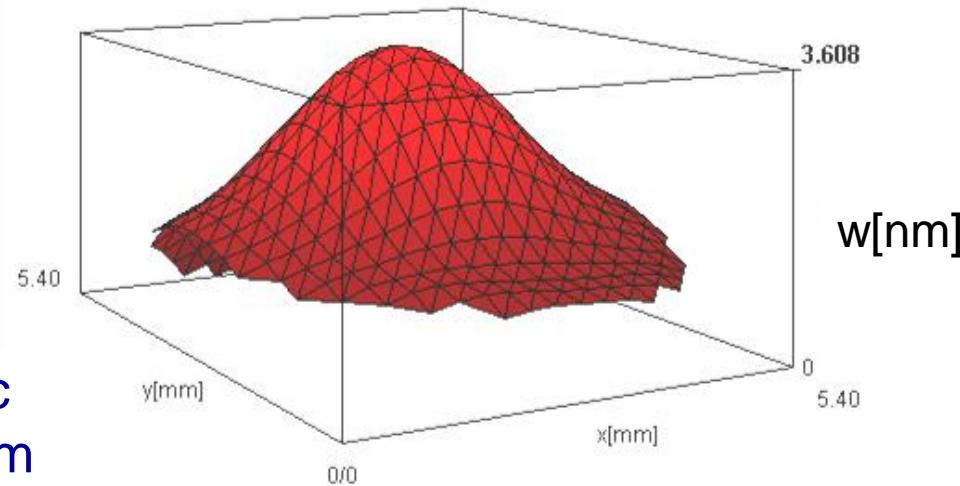


- $\tau \sim \text{sec}$
- $\Delta w \sim \text{nm}$

$$\text{dn/dT: } 8.5 \cdot 10^{-6} \text{ [1/K]}$$

- Reversal of wavefront deformation
- → possibility for compensation of thermal lensing !

CaF₂:



$$-10.5 \cdot 10^{-6} \text{ [1/K]}$$



Summary:



➤ **Laser beam characterization**

- ISO standards

➤ **Hartmann-Shack wavefront sensor**

- beam propagation for single pulses (M^2 , Strehl, $\Delta < 5\%$)
- Wigner distribution \Rightarrow partially coherent beams

➤ **Thermal lensing in beam delivery optics**

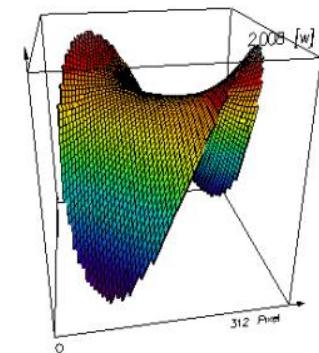
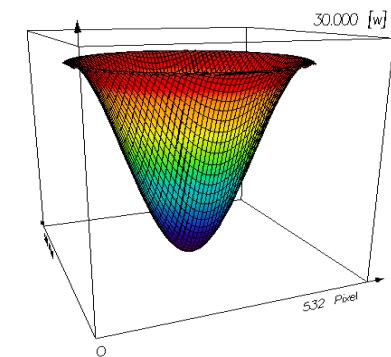
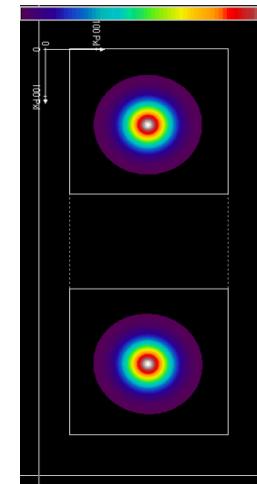
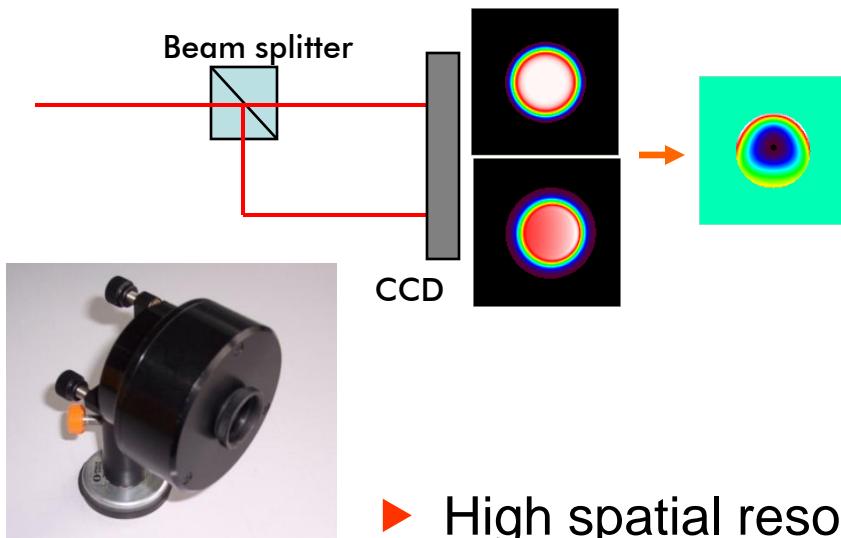
- New photothermal technique for measurements of ***absorption*** and ***focus shift***
- high sensitivity wavefront sensor
- Examples: wavefront distortions @193nm, @1070nm, @532nm F-Theta obj.

Wavefront Curvature Sensor



Wavefront Reconstruction from Intensity Transport Equation:

$$-\partial_z I = \nabla_{\perp} I \cdot \nabla_{\perp} w + I \cdot \Delta_{\perp} w \rightarrow w(x, y)$$



- ▶ High spatial resolution (pixel size)
- ▶ Self-referencing

Thank You !



Coworkers:

- *Dr. B. Schäfer*
- *Dr. U. Leinhos*
- *J.O. Dette*
- *W. Hüttner*
- *F. Kühl*
- *M. Lübbecke*
- *T. Mey*
- *M. Müller*
- *G. Steinert*
- *J. Sudradjat*
- *M. Stubenvoll*

Outlook:



- Separation of surface and bulk effects
- Measurement at other wavelengths: NIR, EUV, x-ray (FEL)
- Prevention of thermal lensing
 - *Reduction of absorption*
 - *compensation → adaptive optics*